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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group art unit: 2818
Examiner: Hoang Quan Tran Ho

In Re PATENT APPLICATION of:

Applicant(s): Masaru TAKAISHI)
U.S. Serial No.: 10/577,360)
U.S. Filing Date: April 28, 2006)
International Serial No.: PCT/JP2004/019732)
International Filing Date: December 24, 2004)
Priority Date Claimed: December 26, 2003)
For: SEMICONDUCTOR DEVICE)
PRODUCTION METHOD AND)
SEMICONDUCTOR DEVICE)
Attorney Reference: AI 411NP)

AMENDMENT

May 5, 2009

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on February 5, 2009, please
amend the above-identified application as follows: